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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Demos et al.

Group Art Unit: 2823

Application No: 10/783,748

Examiner: Khiem D. Nguyen

Confirmation No: 7358

Attorney Docket No:

Filed: February 20, 2004

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Title: CLEAN PROCESS FOR AN

February 28, 2005

**ELECTRON BEAM SOURCE** 

San Francisco, California

## AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

VIA FACSIMILE (703) 872-9306

Examiner Nguyen:

This communication is in response to the Office Communication mailed on September 29, 2004, and is being filed within five months thereof with a two month extension of time fee.

Certificate of Transmission

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted to the U.S. Patent and Trademark Office at (703) 872-9306 on the date shown below.

Christy Hennigan

Date: February 28, 2005